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In re the Application of:

**SHIRATA, Yosuke**

Serial No.: **09/684,898**

Examiner: **NGUYEN, H.**

Filed: **October 10, 2000**

P.T.O. Confirmation No.: **2212**

For: **LITHOGRAPHY SYSTEM AND METHOD**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 11, 2003

Sir:

In response to the Office Action dated February 18, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.